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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q83590

Kenji ISHIDA, et al.

Appln. No.: 10/509,942

Group Art Unit: 3726

Confirmation No.: 4968

Examiner: Douglas Mazzuca, Jr.

Filed: October 1, 2004

For: RECYCLING METHOD AND SYSTEM THEREOF

LETTER

MAIL STOP AMENDMENT

Commissioner for Patents


P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Further to the Information Disclosure Statement filed December 17, 2004, for the Examiner's information, Applicants are providing and attach hereto a copy of an Office Action and its partial English language translation from the Patent Office of the People's Republic of China in a counterpart application (No. 03809200.X). The documents cited in the Chinese Office Action were previously cited and filed in the Information Disclosure Statement filed December 17, 2004, so no additional art documents are listed herewith.

Respectfully submitted,


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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: June 20, 2006